

Application/Control No.	Applicant(s)/Patent under Reexamination
10/689,855	SHIGETA ET AL.
Examiner	Art Unit
Mike Qi	2871

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SEARCHED					
Class	Subclass	Date	Examiner		
349	134,123; 124,125; 127,130	9/29/2006	ZQQ		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NO' (INCLUDING SEARCH)
	DATE	EXMR
East search US-PGPUB;USPAT;USOCR;FPRS, EPO;JPO;DERWENT;IBM_TDB; update search (see printout)	9/29/2006	ZQQ
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